

<b>Notice of References Cited</b>	Application/Control No. 10/544,133		Applicant(s)/Patent Under Reexamination AZAMI ET AL.	
	Examiner DANIEL C. MCCracken		Art Unit 1793	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,876,684	03-1999	Withers et al.	423/445B
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

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#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Ullmann, et al., Nanoparticle formation by laser ablation, J. Nanoparticle Research 2002; 4: 499-509
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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